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Deep oxidation of methane on particles derived from YSZ-supported Pd-Pt-(O) coatings synthesized by pulsed filtered cathodic arc.

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21
22 **Abstract**

23
24 Methane conversion tests were performed on Pd, PdO_y, Pd_{0.6}Pt_{0.4}O_y and Pd_{0.4}Pt_{0.6}O_y
25 thin films deposited on yttria stabilized zirconia (YSZ) substrates. Pt containing films
26 exhibited poor activity and high reducibility. As-deposited Pd and PdO_y films showed
27 good activity and transformed, during the cycling process, to particles dispersed on
28 the YSZ substrates. The higher reaction rate of initially PdO_y films was explained by a
29 better dispersion of the catalyst. A drop of the reaction rate was observed when the
30 temperature exceeded 735°C and 725°C for initially Pd and PdO_y, respectively,
31 which can be associated with the high-temperature reduction of PdO into Pd.

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34 **1. Introduction**

35 Improving the efficiency for the catalytic combustion of methane (CH₄) represents
36 a challenge for the reduction of working temperature of CH₄ combustion turbines.
37 Palladium catalysts have been shown to belong to the most effective catalysts for
38 methane combustion (e.g. [1–6]) and to be more active than other transition metals
39 for this reaction [5,7,8]. While bulk PdO is claimed to be inactive, a thin layer of PdO
40 on metallic Pd is proposed to be the active form of palladium [8-10]. It was suggested
41 that CH₄ combustion occurs via the Mars–van Krevelen mechanism where O₂ is
42 assumed to oxidize the palladium surface, the formed surface oxide being reduced
43 by CH₄ [4]. A bifunctional mechanism for methane oxidation over Pd/ZrO₂ catalysts
44 has already been suggested, where metallic Pd particles dissociatively chemisorb
45 methane producing adsorbed H and CH_x species [8,10]. Reoxidation rapidly converts
46 the metal back to the oxide. The predominance of either metallic palladium-supported
47 PdO or a Pd/PdO_y mixture for active oxidation of methane is still highly controversial.
48 For Al₂O₃ support, the incorporation of Pt in Pd has been reported to improve and
49 stabilize the catalytic oxidation of methane via Pd-Pt interaction (e.g. [12, 13]). On the
50 contrary, Persson *et al.* observed superior conversion efficiency for Pd than Pd-Pt
51 equimolar mixture, the latter presenting higher long term stability [14].

52 Pulsed Filtered Cathodic Vacuum Arc (PFCVA) can be successfully employed to
53 deposit various chemical systems such as diamond like carbon (DLC), metal doped
54 DLC [15, 16] and metal oxide [17, 18] films. The high reactivity of the evaporated
55 species associated with the technique and the use of a dual cathode deposition
56 system (DC-PFCVA) is expected to lead to the successful synthesis of binary and
57 ternary noble metal oxide films. In the present study, yttria stabilized zirconia (YSZ)
58 supported Pd-based catalysts were considered due to the applicability of YSZ

59 supports to solid oxide fuel cells and car engine exhausts where electrochemical
60 promotion of catalysis start being considered [19, 20]. This study presents DC-
61 PFCVA as a suitable technique to synthesize various metallic or oxide thin films for
62 catalytic reactions, and explores the thermal evolution of the catalytic activity for YSZ-
63 supported metallic Pd, Pd oxides and Pd_xPt_{1-x} oxides.

65 2. Experimental

67 2.1. Sample preparation

68 Metallic Pd, Pd oxide and Pd_xPt_{1-x} oxide films were prepared on YSZ pellets (14
69 mm in diameter, 1 mm thick). The system contains a dual-cathode “triggerless” mini-
70 gun [21], which was designed to operate in pulsed mode. The two cathodes
71 incorporated in the source were pure palladium and platinum. The pulsed operation
72 of these cathodes was controlled using a custom National Instruments' LabView™
73 software. Once the computer has sent a signal to the arc power supply, an arc
74 discharge pulse on a selected cathode is triggered simply by application of a high
75 open circuit voltage (of about 600 V). The pulsed arc current employed was about
76 700 A with a pulse duration of about 1 ms. A pulse repetition rate of four pulses per
77 second was employed for all films. The two mixed Pd_{1-x}Pt_xO_y films were deposited
78 by alternating one platinum pulse and one palladium pulse for the higher Pt-
79 containing Pd_{1-x}Pt_xO_y film, and one platinum pulse for every two palladium pulses for
80 the lower Pt-containing Pd_{1-x}Pt_xO_y film. The plasma stream produced by the mini arc
81 source was injected into a 90-degree filter to remove most of the macroparticles,
82 which were formed during the cathodic arc evaporation process [22]. After exiting the

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83 90-degree filter, the plasma stream travelled through a magnetic multipole
84 homogenizer with 16.7 cm inner diameter in order to improve the film uniformity [22].
85 The substrate holder was grounded and rotated at a rate of 2 revolutions per minute
86 during the deposition. The distance between the exit of the filter to the homogenizer
87 was about 3 cm, and the distance from the magnetic homogenizer to the substrate
88 was about 2 cm. The vacuum base pressure was typically in the 10^{-4} Pa range, the
89 process pressure was set at approximately 2.13 Pa (16 mTorr). For the deposition of
90 the pure palladium film, pure Ar was used as process gas while for the deposition of
91 the oxide films pure oxygen was introduced to the chamber at 16 standard cubic
92 centimeters per minute. The films were deposited at the same time on cubic YSZ
93 pellets and silicon wafer pieces.

94

95 2.2. Sample characterization

96 The structural characteristics of the films were probed by grazing incidence X-ray
97 diffraction (GIXRD) at an incident angle of 2° with respect to the substrate surface.
98 The experiments were done with a Co-K α source (wavelength of 0.178897 nm) using
99 an INEL diffractometer. The film composition was measured by secondary neutral
100 mass spectrometry (SNMS) with an 8 keV Ar $^+$ primary beam. The apparatus is a
101 SimsLab-VG. The typical currents on the samples were in the range 300-500 nA and
102 the sputtered atoms were post-ionised by the electrons emitted from a filament for
103 the mass spectrometry analysis. The quantification procedure of the relative Pd and
104 Pt content and the estimate of the oxygen content of as-grown films included, first, a
105 calibration of the SNMS measurements using thick crystalline Pt $_2$ O and PdO
106 sputtered reference films, as well as SNMS measurements of a thick Pd $_{0.85}$ Pt $_{0.15}$ O $_y$

107 film whose metals stoichiometry was previously determined by energy dispersive
108 spectroscopy (EDS). The compositions of thin catalyst films were then deduced
109 from the integration of the SNMS profile corrected using the calibration. The surface
110 of the Pd-based catalysts was observed by scanning electron microscopy (SEM,
111 XL30S FEG Philips). Thickness measurements were carried out with a Dektak IIA
112 profilometer on films deposited on flat silicon substrates.

113 Catalytic measurements were performed at atmospheric pressure in a specific
114 quartz reactor described in a previous study [23, 24]. The catalysts were placed on
115 sintered quartz, 18 mm in diameter. The reactive mixture passed through the porous
116 disk from below and then licked the catalyst surface. A K-type thermocouple was
117 located close to the catalytic surface. The reaction gases were mixtures of CH₄ (Air
118 Liquide, 5% CH₄ in He) and O₂ (Air Liquide 5% O₂ in He). The gas composition was
119 controlled by mass flow controllers (Brooks, with accuracies better than 1%). In the
120 following, the gas composition will be expressed in ppm or %. The reactive mixture
121 (RM) is containing CH₄/O₂: 5100 ppm/4%. The overall gas flow rate was kept with He
122 constant at 72 mL min⁻¹ (+/- 2 mL min⁻¹). To study the catalytic performance and the
123 thermal ageing, three cycles were performed between 250°C and 800°C at a ramp of
124 10°C min⁻¹ with a plateau of two hours at 800°C for each sample. The comparisons
125 between catalytic surfaces of Pd, PdO, and Pd_xPt_{1-x}O_y were performed during
126 cycling. The reactants and products were analysed by an IPC400TM INFICON
127 quadrupole mass spectrometer. Signals at m/e = 15, 18, 28, 32, 44 amu
128 corresponding to CH₃⁺, H₂O⁺, N₂⁺ or CO⁺, O₂⁺ and CO₂⁺ ions, respectively, were
129 recorded. The conversion of methane was defined as the percentage of methane

130 feed converted into CO₂. Carbon dioxide was the only oxidation product detected.

131 The catalytic rate was calculated in reference to the palladium loading.

132

133 3. Results and discussions

134

135 Some characteristics concerning catalytic coatings are reported in Table. 1. The
136 as-deposited Pd films were found to be nanocrystalline with an average grain size of
137 about 10 nm while all the oxide films were amorphous. SEM examination of the
138 samples revealed a complete coverage of the YSZ surface by the deposited
139 materials with a dense morphology. While palladium oxide, PdO, and platinum
140 dioxide, PtO₂, are stable in air at low temperatures, they start reducing in air at
141 around 750°C [7] and 450°C [25], respectively. The estimated oxygen content in the
142 as-deposited films (y) decreases with the incorporation of Pt. The methane
143 conversion curves of the deposited films upon heating after a first RT-800°C-RT (RT:
144 room temperature) thermal cycle are displayed on Fig. 1a. The Pd, PdO _{y} coatings
145 promote methane deep oxidation upon heating below 770°C whereas the promotion
146 by the Pd_{0.6}Pt_{0.4}O _{y} film stops at roughly 750°C. The highest conversions occurred for
147 as-deposited Pd and PdO _{y} films. Very low catalytic activity is observed on
148 Pd_{0.4}Pt_{0.6}O _{y} film. The present results are in accordance with the detrimental effect of
149 Pt incorporation into Pd_{1- x} Pt _{x} for $x \geq 0.33$ reported by Persson *et al.* for the same
150 reaction [14].

151 For a better comparison of the different catalysts, the reaction rate has been
152 calculated in reference to the palladium loading (Fig.1 b). The representation
153 highlights a superior catalytic activity of as-deposited palladium oxide films compared

154 to metallic palladium. The behavior of Pd_{0.6}Pt_{0.4}O_y is characterized by lower activity
155 between 580°C and 680°C. This might be related to the onset of the reduction of
156 oxidized platinum. In this context, it is worth noting that Seriani *et al.* calculated a
157 higher efficiency of platinum oxide (Pt₃O₄) than Pt for CH₄ cracking [26]. We believe
158 that the strong platinum reducibility explains the improved reducibility of the
159 compound, leading to a reaction rate drop at 680°C for Pd_{0.6}Pt_{0.4}O_y and of the
160 negligible activity for Pd_{0.4}Pt_{0.6}O_y.

161 The thermal cycling behavior of the as-deposited Pd and PdO_y films is shown in
162 Fig. 2. Starting from metallic palladium, the onset of the catalytic conversion is
163 observed at 550°C upon the first heat up, whereas PdO_y is already active at 400°C.
164 The reaction rate drops at 735°C and 725°C for initially Pd and PdO_y films,
165 respectively. These temperatures cause the reduction of PdO into metallic Pd. They
166 are higher than the 700°C reported in oxidizing mixtures by Furuya *et al.* for Pd
167 nanoparticles on YSZ [27], and the 715°C reported by Roche *et al.* for 52-nm thick
168 Pd thin films sputter-deposited on YSZ [28]. Cooling down the samples from 800°C,
169 surface re-oxidation occurs, thereby restarting the conversion the hydrocarbons.
170 However, the reoxidation of the surface occurs at a lower temperature than the
171 reduction upon heating. Both materials exhibit an activity hysteresis of about 100°C.
172 The phenomenon is qualitatively consistent with the original observation by Farrauto
173 *et al.* for Al₂O₃-supported Pd [7]. The thermal cycling of PdO_y did not give any
174 evidence for strong differences between the cycles. In the case of Pd, the first
175 heating is associated to a lower activity. This indicates a strong structural or/and
176 chemical evolution of the Pd film during the first heating. From the previous
177 discussion, the reducibility of the compounds drives the thermal evolution of the
178 catalytic activity. Palladium was the only crystalline as-deposited film. The GIXRD

179 signature of the different samples after the third cycle is represented on Fig.3. These
180 investigations interestingly highlight that the final structural state is very sensitive to
181 the initial composition:

- 182 • The only phase detected for Pt-containing films is metallic (no Pt oxide).
- 183 • The as-deposited Pd film transformed into a biphased alloy consisting of Pd and
184 PdO.
- 185 • The as-deposited PdO_y film converted into crystalline PdO. The reddish colour
186 characteristic of PdO could be observed only for that sample.

187
188 Therefore, the hypothesis of the higher reducibility of Pt-containing films is confirmed.

189 The SEM observation of both initially Pd and PdO_y films shows an important
190 evolution of the morphology towards clusters of particles dispersed at the surface of
191 the zirconia substrate (Fig. 4). PdO_y evolved in jagged clusters of few particles with a
192 characteristic size of the particles close to 100 nm. The clusters derived from the Pd
193 film are bigger and more spherical in shape. Significant coalescence occurred
194 between the particles. The differences in shapes and sizes are linked to strong
195 differences in the surface to volume ratio. Using a spherical approximation for the
196 particle shape, the dispersion of the catalyst was estimated to 6 and 16 % for initially
197 Pd and PdO_y films respectively. Assuming a surface oxidation for both compounds
198 within the thermal domain of active heterogeneous catalysis, the latter parameter
199 obviously explains the discrepancy between the maximal activities of the two
200 compounds.

201

202 **Conclusions**

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204 Methane conversion tests were performed on Pd, PdO_y, Pd_{0.6}Pt_{0.4}O_y and
205 Pd_{0.4}Pt_{0.6}O_y thin films deposited by Dual Cathode Filtered Cathodic Vacuum Arc on
206 YSZ substrates. The catalytic activity curves over thermal cycling were discussed in
207 terms of the reducibility of the deposited compounds. The film with the highest Pt
208 content exhibited poor activity and Pd_{0.6}Pt_{0.4}O_y showed limited activity and high
209 reducibility. In contrast, during the cycling process, the as-deposited Pd and PdO_y
210 films showed good activity despite the transformation to clusters of particles
211 dispersed on the YSZ substrates. The higher reaction rate of the initially PdO_y films
212 was explained by a better dispersion of the catalyst. The drop in the reaction rate,
213 associated with the reduction of PdO into Pd at high temperature, was measured at
214 735°C and 725°C for the initially Pd and PdO_y films, respectively. After three thermal
215 cycles up to 800°C, it was not possible to detect either Pd or Pt oxides in the Pt
216 containing films. As-deposited Pd evolved to a Pd/PdO mixtures, only crystalline PdO
217 was detected for initially PdO_y amorphous films.

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270 **Table caption**

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272 Table 1: Some characteristics of the deposited catalysts. * As-deposited.

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282 **Figure captions**

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284 Figure 1: Methane conversion a), methane reaction rate in reference to the Pd load
285 b) over the deposited compounds during the second heat up from 250°C to 800°C.

286
287 Figure 2: Evolution of the methane reaction rate during thermal cycling.

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289 Figure 3: X-ray diffraction patterns of the deposited compounds after thermal cycling.

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291 Figure 4: PdO particles derived from thermally cycled PdO_y films deposited films a),
292 mixed PdO + Pd particle clusters derived from thermally cycled Pd films deposited
293 films b).

294

Figure 1a

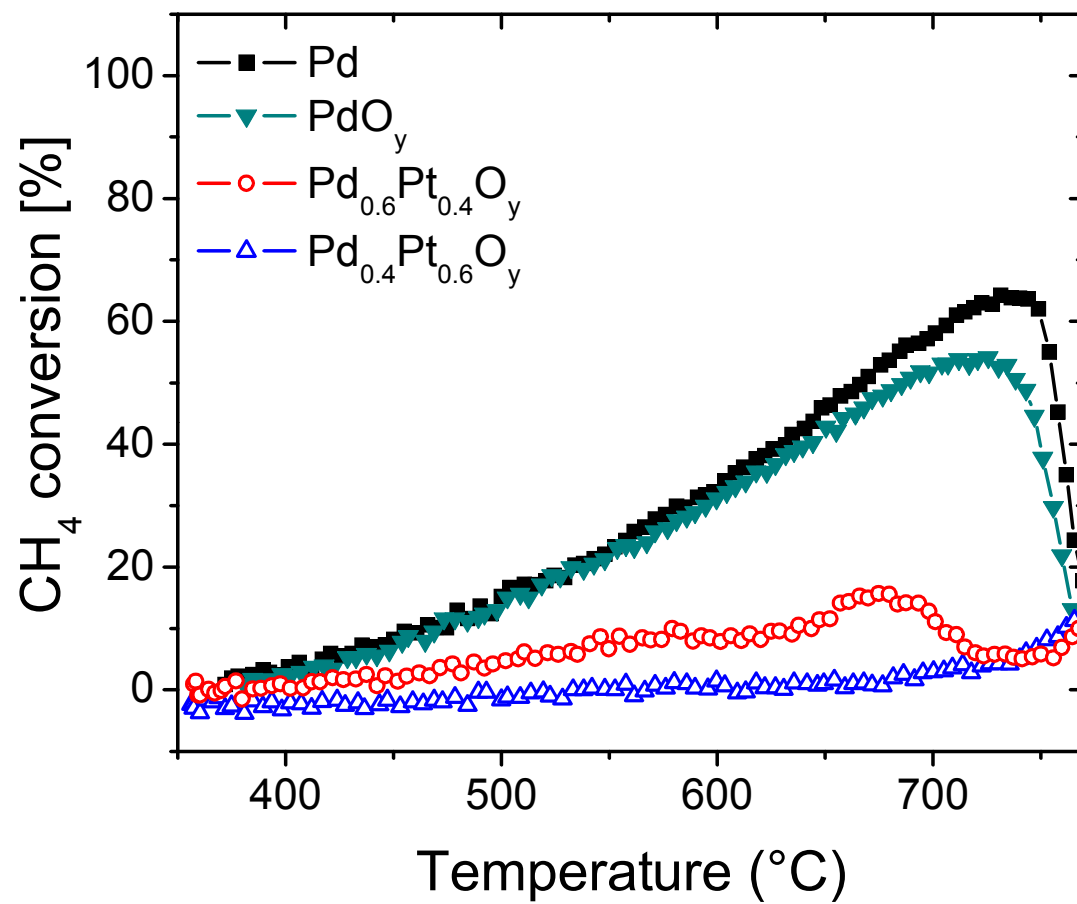


Figure 1b

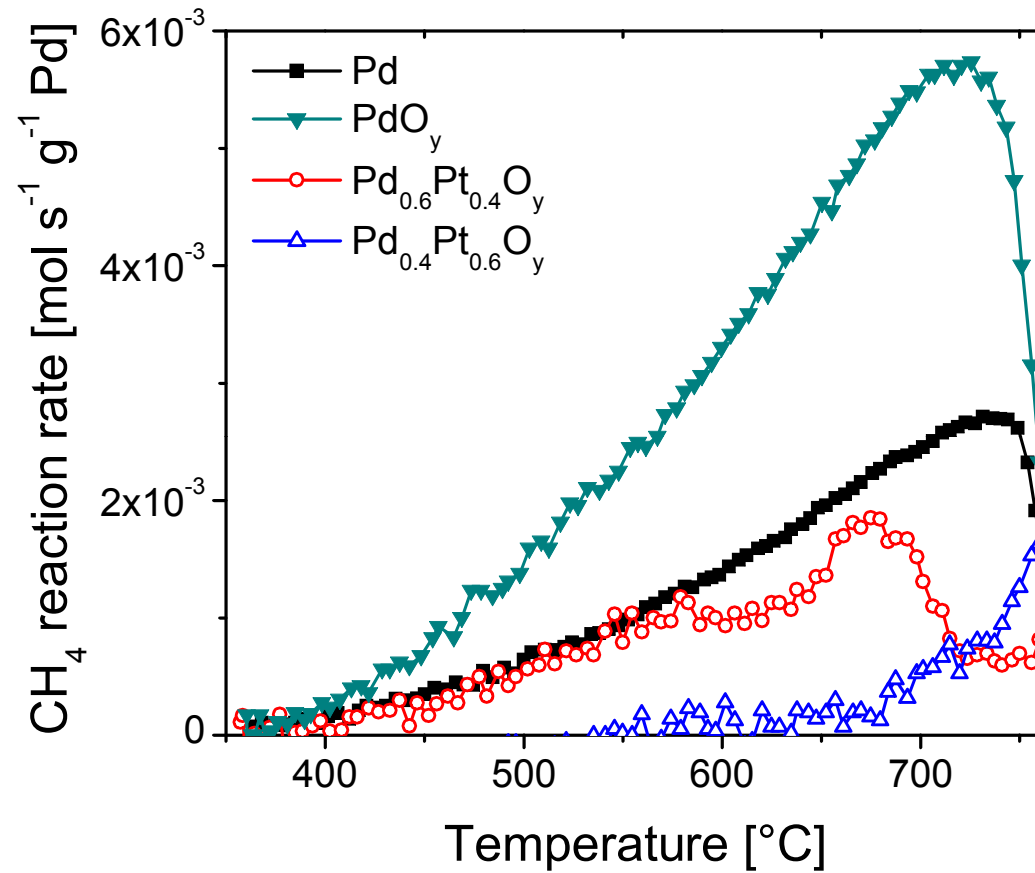


Figure 2

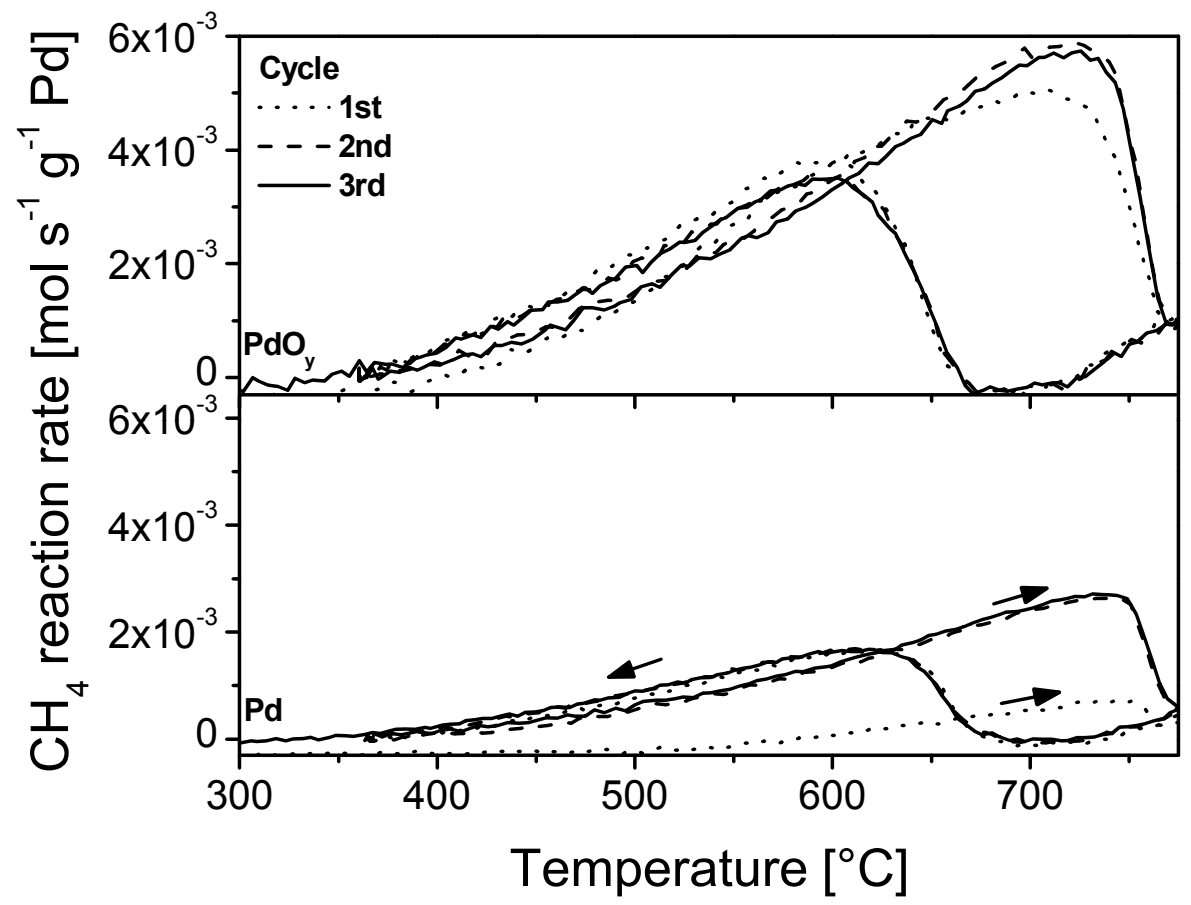


Figure 3

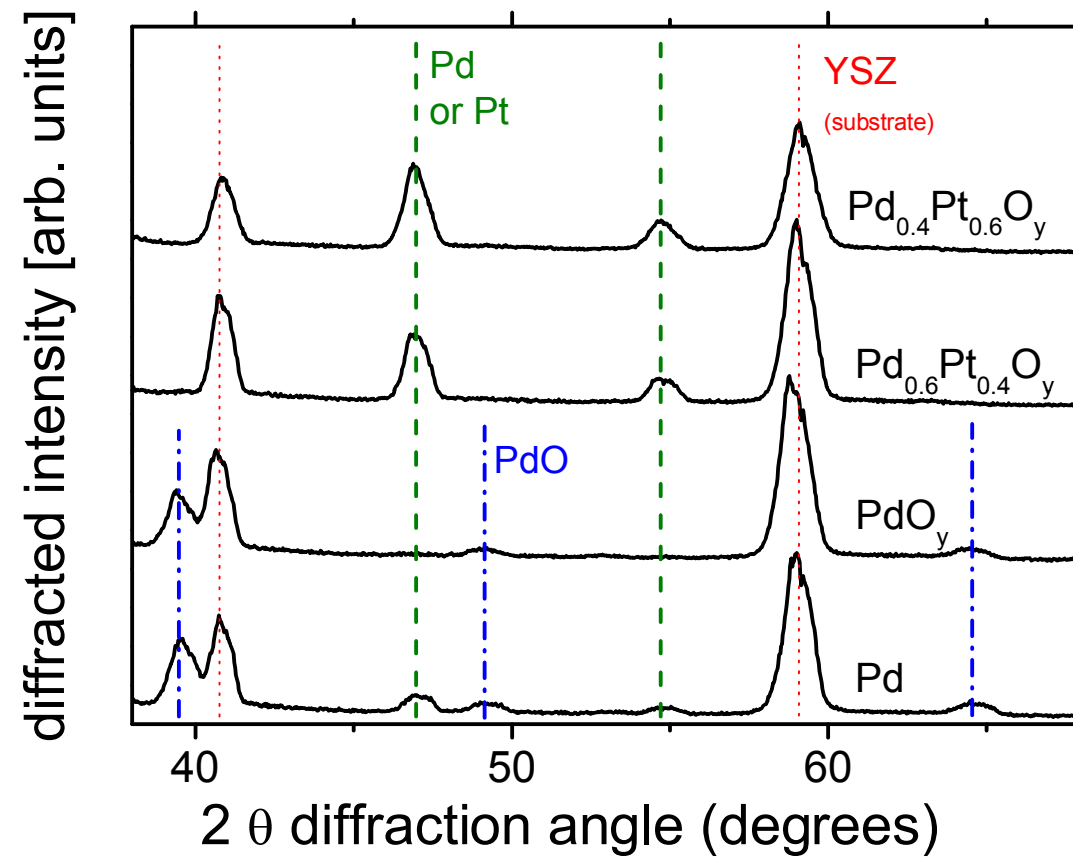


Figure 4

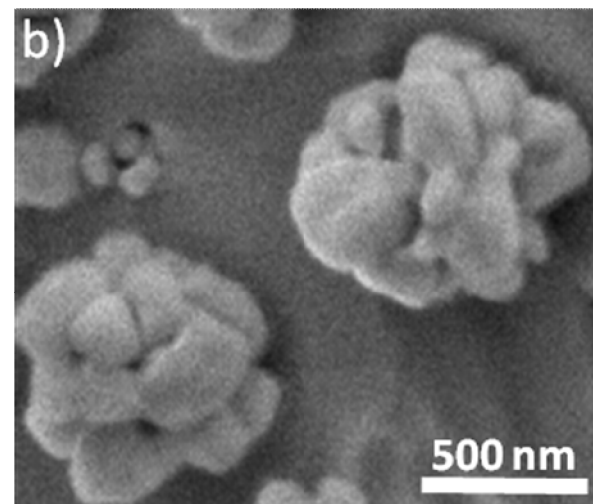
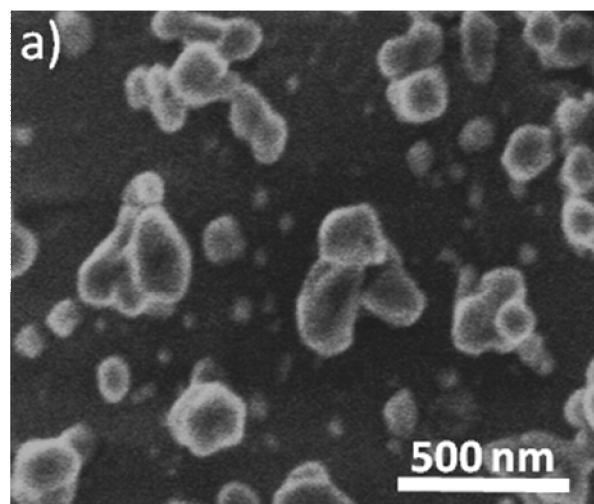


Table 1

Composition	Initial structure	Thickness (nm)	Oxygen/Metal (y) *	Pd loading (μg)	Final structure (3 cycles)	Maximal catalytic rate ($\text{mmol CH}_4 \text{s}^{-1} \text{g}^{-1} \text{Pd}$)
Pd	nano-crystalline (~10 nm)	45	/	83	Pd + PdO	2.57
PdO_y	amorphous	34	0.96	40	PdO	5.9
Pd_{0.6}Pt_{0.4}O_y	amorphous	37	0.74	36	Metal	1.85
Pd_{0.4}Pt_{0.6}O_y	amorphous	35	0.63	23	Metal	/